



1/2/03  
#14(CDS)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/885,393  
Filing Date ..... June 19, 2001  
Inventor ..... Richard Holscher et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 1756  
Examiner ..... Kathleen Duda  
Attorney's Docket No. .... MI22-1694  
Title: Semiconductor Processing Methods

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References –See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: \_\_\_\_\_

12/20/02

By: \_\_\_\_\_

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